

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	30	transducer.ti. and(peripheral adj rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 08:29
L2	5	1 and(wafer\$1)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 08:36
L3	21	MEMS.ti. and rim	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 08:40
L4	9	361/277 and rim	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:14
L5	14	"4814845"	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:16
L6	35	"3748571"	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:34
L7	1	361/281 and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:35
L8	28	361/283 and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:41
L9	1	361/277 and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:36
L10	2	361/287 and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:42
L11	0	361/290 and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:41
L12	8	capacitor.ti. and(surround\$3 with rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:44
L13	708	capacitive with sensor.ti.	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:46
L14	20	capacitive with transducer.ti. and(rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:44
L15	0	capacitive with "sensor.ti.and"(rim)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:44

L16	12	capacitive with sensor.ti. and(second adj wafer)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 09:49
L17	3	capacitive with sensor.ti. and(semiconductor adj plate)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:40
L18	1420	pressure with transducer.ti.	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:41
L19	4	18 and(semiconductor adj plate)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:42
L20	329	361/283.1 and(transducer or sensor)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:42
L21	146	20 and(dielectric)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:48
L22	14	21 and(rim\$1)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:55
L23	14	361/287 and transducer	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:57
L24	26	361/292 and transducer	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:00
L25	8	361/287 and pressure adj sensor	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 10:58
L26	1	361/298.5 and transducer	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:01
L27	9	361/298.5 and sensor	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:02
L28	179	mems with transducer	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:02
L29	18	361/303 and(transducer)	US-PGPUB; USPAT; JPO	AND	OFF	2004/11/26 11:48